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Attorney's Docket No.: 10417-118001 / F51-142893M/SW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Yoshinori Hino et al.

Art Unit : 2826

Serial No. : 10/076,154

Examiner : Tan N. Tran

Filed : February 14, 2002

Title : SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Copies of the references listed on the attached form PTO-1449 are enclosed.

English-language abstracts for both references are also enclosed. A copy of an Office action from the Korean Patent Office, as well as an English-language translation, also is enclosed.

This statement is being filed after a Notice of Allowance, but before payment of the issue fee. Each item of information in this statement (i) was cited in the enclosed Office Action from the Korean Patent Office in a counterpart foreign application, the Office Action being dated September 23, 2004, which is not more than three months prior to the filing of this statement, and (ii) to the knowledge of the undersigned, was not first cited in any communication from a foreign patent office in a counterpart application which was more than three months prior to the filing date of this statement. A check for \$180 in payment of the late submission fee of C.F.R. §

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Attorney's Docket No.
10417-118001

Application No.
10/076,154

**Information Disclosure Statement
by Applicant**
(Use several sheets if necessary)

Applicant
Yoshinori Hino et al.

Filing Date
February 14, 2002

Group Art Unit
2826

U.S. Patent Documents

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation Abstract	
							Yes	No
	AL	09-148526	06/06/1997	Japan			X	
	AM	2000-174268	06/23/2000	Japan			X	
	AN							
	AO							
	AP							


Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document
	AQ	
	AR	
	AS	
	AT	

Examiner Signature

Date Considered

EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Attorney's Docket No. 10417-118001	Express Mail Label No. ET931344527US	Mailing Date December 21, 2004	For PTO Use Only Do Not Mark in This Area 
Application No. 10/076,154	Filing Date February 14, 2002	Attorney/Secretary Init SXB/gzm	
Title of the Invention SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF			
Applicant Yoshinori Hino et al.			
Client Reference No. F51-142893M/SW			
Enclosures · Information Disclosure Statement (2 pages) · Check for \$180.00 · Form PTO-1449 (1 page) · Documents listed on the Form PTO-1449 (2 documents) · Other: Copy of Korean Office Action (9/23/04) 